## EXHIBIT B

## 3577 Barley Court San Jose, CA 95127-4401

May 19, 2003

Tara Hayden Patent Secretary for James E. Austin Beyer Weaver & Thomas 2030 Addison St. Suite 700 Berkeley, CA 94704-1144

Dear Tara Hayden:

Re: Your letters dated May 9, 2003 and the U.S. Patent Applications LSI1P212 & LSI1P223

I am returning the two U.S. patent applications, Vaporization and Handling of Metals for Use in Semiconductor Processing by James Kimball and Sheldon Aronowitz and Vaporization and Ionization of Metals for Use in Semiconductor Processing by James Kimball and Sheldon Aronowitz, unread and unsigned.

I am no longer employed by LSI Logic. If a satisfactory consultative arrangement between LSI Logic and myself can be established, I would be happy to analyze, critic, and subsequently sign the documents.

Sincerely,

Sheldon Aronowitz

Encl.: U.S. Patent Applications LSI1P212 & LSI1P223 and two cover letters from

Tara Hayden